

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KANO et al.**

Group Art Unit: **2812**

Serial No.: **09/941,982**

Examiner: **Mulpuri, Savitri**

Filed: **August 30, 2001**

P.T.O. Confirmation No.: 7536

For. **METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR LAYER, AND  
METHOD OF MANUFACTURING NITRIDE-BASED SEMICONDUCTOR  
DEVICE**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: May 5, 2004

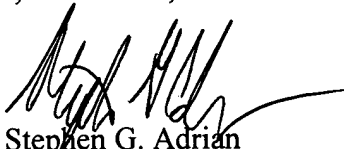
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated November 5, 2003 for three months from February 5, 2004 to May 5, 2004.

Attached please find a check in the amount of \$950.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866. This paper is filed in triplicate.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

  
Stephen G. Adrian  
Attorney for Applicants  
Reg. No. 32,878

SGA/arf

Atty. Docket No. **011083**  
1250 Connecticut Avenue, N.W.  
Suite 700  
Washington, D.C. 20036  
(202) 822-1100

05/06/2004 SSESHE1 00000036 09941982 950.00 00  
01 FC:1253